

## 129630 Micro Vacuum Probe Stations

**Solartron Analytical and Nextron have joined forces to provide a wide range of temperature controlled micro vacuum probe systems for testing ceramics, polymers, sensors, and solid state materials.**

As the “micro” name implies these probe stations are extremely small (140 mm / 5.5”) and portable so you can easily move the test station from one experiment to the next.

Systems can be configured to your specific requirements using reference grade system components including:

- ▶ Solartron Analytical’s range of high precision time domain / EIS electrical measurement instrumentation including:
  - ModuLab XM MTS
  - MaterialsLab XM
  - 1260A /1296A
- ▶ Nextron’s range of 4-probe micro vacuum probe stations built from the highest-quality aerospace materials, include cryostatic and high temperature variants for characterizing your materials over the temperature range -195 °C to 750 °C.

These reference grade test systems are perfectly suited to studying your materials (dielectric, ionic, semiconductor, electronic) and their interfaces (e.g. grain boundaries and electrodes).

### Applications include:

- ▶ Development of advanced ceramic materials
- ▶ High temperature dielectrics and insulators
- ▶ Fuel cell and solid electrolyte materials
- ▶ Studies of bulk and interfaces; grain boundaries and electrodes
- ▶ Electroceramics
- ▶ Electronic and display materials
- ▶ Sensor materials

### Micro Vacuum Probe Stations

Compare the following amazing facilities:

- ▶ Small, light, portable - convenient to move around your laboratory
- ▶ Small size allows fast / responsive temperature changes
- ▶ Four electrodes, can be used in 2, 3 or 4 terminal configurations
- ▶ Short working distance is optimized for light emission tests using microscopes
- ▶ Gas tight sample space - test samples in vacuum or atmosphere including humidity measurement

The following product variants are available:

#### Peltier 129630 PT/PTH

- ▶ -40°C to 200°C with light emission options

#### Ceramic 129630 CHL/CHH

- ▶ RT to 450° / 750°C

#### Liquid Nitrogen 129630 LN2

- ▶ 77K to 300K

### Solartron materials test systems...

Solartron materials test systems provide a wide range of electrical measurements including I-V, Pulse, C-V, Impedance, and Mott-Schottky.

- ▶ PC software provides fully integrated electrical measurements with temperature control
- ▶ High and low impedance materials can be analyzed depending on the choice of instrumentation and sample holder configuration
- ▶ Wide frequency range from 10 μHz to 32 MHz enables full materials characterization



## 129630 Series Micro Vacuum Probe Stations

Electrical connections	Four spring loaded probes positioned on the sample surface - can be used in 2, 3, or 4 probe mode
4-point probing method	Free-stop
Probe stroke length (x-axis)	12 mm
Sample chamber volume	<100 cc
Vacuum sample chamber leak rate	1 x 10 <sup>-7</sup> L.Torr/s
View port (for microscope)	40 mm diameter (sapphire or fused-silica)
Vacuum/vent connections	2x 1/4" standard Swagelock
Electrical connections	4x SMA (female)
Controller Interface	RS485 (serial port)
Dimensions (w.d.h)	140 mm x 70 mm x 24.5 mm
Weight (probe station)	650 g
Control unit voltage	100-220 V, 50-60 Hz
Control unit power	76 W (PT/PTH/LN2), 150 W (CHL/CHH)

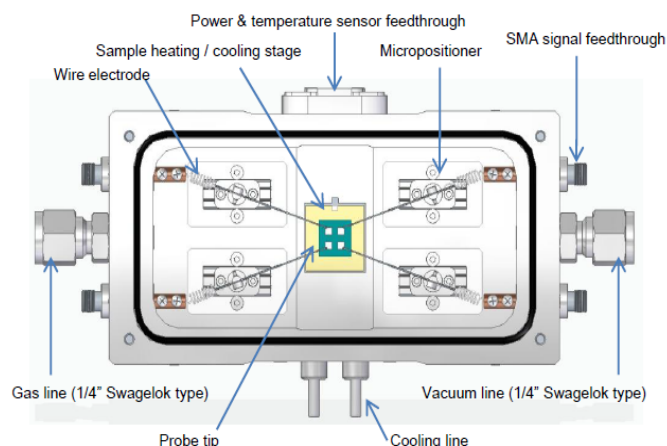
### Options

Vacuum pump	129631A
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### System Compatibility

Nextron Micro Vacuum Probe Stations are fully compatible with Solartron Analytical materials test products, including:

- 1260A Impedance Analyzer
- 1296A Dielectric Interface (with 12xx FRA or 1260A)
- ModuLab XM MTS Materials Test System
- MaterialsLab XM Materials Test System
- XM-studio and SMaRT software



## 129630PT/PTH Micro Vacuum Probe Station (Peltier)

Temperature range	-40°C to +200°C (active cooling)
Heater type	Peltier
Probe material	Gold-coated inconel
Sample stage size	18 x 18 mm
Maximum cooling / heating rate	1°C/sec
Temperature accuracy	±0.1°C
PTH variant	Light irradiated from under sample

## 129630CHL/CHH Micro Vacuum Probe Station (Ceramic)

Temperature range	CHH - Room temperature to +750°C CHL - Room temperature to +450°C
Heater type	Ceramic Heater
Probe material	Bulk rhodium
Sample stage size	12.7 mm diameter
Maximum cooling / heating rate	1°C/sec
Temperature accuracy	±0.5°C

## 129630LN2 Micro Vacuum Probe Station (Liquid Nitrogen)

Temperature range	77K to 300K (includes LN dewar)
Heater type	Liquid nitrogen (Dewar)
Probe material	Gold-coated inconel
Sample stage size	18 mm diameter
Maximum cooling / heating rate	20K/sec
Temperature accuracy	±0.1K

Test Capability	129630 P/C/LN			Equip	
	P	C	LN	XM	12xx
I-V measurement (2, 3, 4 probe)	✓	✓	✓	✓	
EIS (Electrical Impedance Spectroscopy)	✓	✓	✓	✓	✓
Capacitance, Mott-Schottky, Dielectrics	✓	✓	✓	✓	✓
Electro/photoluminescence & photovoltaic	✓	✓	✓	✓	✓
Photocurrent mapping	✓			✓	
Semiconductor characterization	✓	✓	✓	✓	✓
Sensors and solid-state materials	✓	✓		✓	✓
Display materials characterization	✓	✓	✓	✓	✓
Thermal hysteresis and conductivity	✓	✓	✓		
Hall measurement			✓		
Raman, reflectivity	✓	✓	✓		
Ferroelectric materials	✓	✓		✓	✓

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